SEP 2 5 2006

I be early certify that this correspondence is being deposited with the United to the correspondence is the correspondence in the correspondence is the correspondence in the correspondence is the correspondence in the correspondence in the correspondence is the correspondence in the correspondence

AMENDMENT UNDER 37 CFR 1.116 EXPEDITED PROCEDURE – EXAMINING GROUP 1765

Mail Stop AF Commissioner for Patents

P.O. Box 1450 Alexandria, VA 22313-1450

Alexandria, VA 22313-1450

7/21/06

PATENT Attorney Docket No.: 16869N-099100US

Client Ref. No.: NT1355US

TOWNSEND and CREW LLP

By:

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Ryo NAKAGAKI et al.

Application No.: 10/699,528

Filed: October 31, 2003

For: METHOD AND SYSTEM FOR

MANUFACTURING A

SEMICONDUCTOR DEVICE

Customer No.: 20350

Confirmation No. 4228

Examiner:

Kin-Chan Chen

Technology Center/Art Unit: 1765

AMENDMENT UNDER 37 CFR 1.116 EXPEDITED PROCEDURE EXAMINING

GROUP 1765

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed April 25, 2006 on the above-referenced application, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.